

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Satitpunwaycha et al.

Serial No.: 10/782,300

Filed: 02/18/04

For: Tuned Potential Pedestal for  
Mask Etch Processing  
Apparatus

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Confirmation No.: 4286

Group Art Unit: 1763

Examiner: Rakesh Kumar Dhingra

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Dear Sir:

## CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Rakesh Kumar Dhingra, on the date shown below:

April 25, 2006

Date

  
Randol W. Read

## RESPONSE TO OFFICE ACTION DATED JANUARY 25, 2006

In response to the Office Action dated January 25, 2006, having a shortened statutory period for response set to expire on April 25, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/008403/RWR, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Specification** begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper. **Remarks** begin on page 8 of this paper.